



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2851

03560.002735

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Kazuhiro TAKAHASHI et al. ) : Examiner: H. Nguyen  
Application No.: 09/749,926 ) : Group Art Unit: 2851  
Filed: December 29, 2000 ) :  
For: EXPOSURE APPARATUS ) : January 8, 2004

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

*Approved for entry* AMENDMENT AFTER FINAL REJECTION

Sir:

1/21/04  
HM  
In response to the Official Action dated October 8, 2003, please amend the above-identified application as follows: